



**ELECTRONIC COPY**

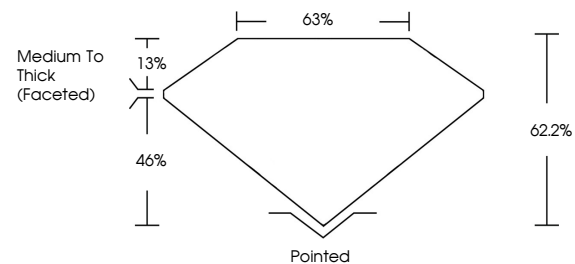
LG783624870  
Report verification at [igi.org](http://igi.org)



March 17, 2026  
IGI Report Number **LG783624870**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **8.94 X 6.21 X 3.86 MM**  
**GRADING RESULTS**  
Carat Weight **1.37 CARAT**  
Color Grade **E**  
Clarity Grade **VS 1**

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**PROPORTIONS**

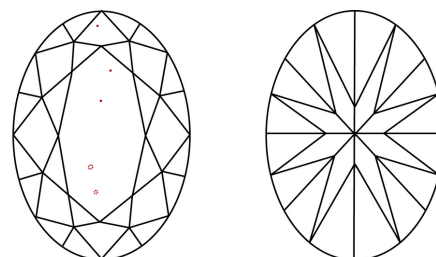


Sample Image Used

**GRADING RESULTS**

Carat Weight **1.37 CARAT**  
Color Grade **E**  
Clarity Grade **VS 1**

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG783624870**

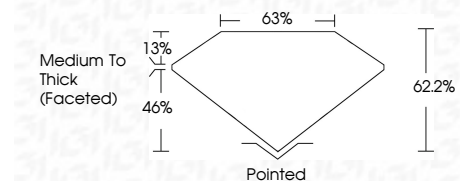
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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**IGI**



March 17, 2026  
IGI Report No **LG783624870**  
**OVAL BRILLIANT**  
Carat Weight **1.37 CARAT**  
Color Grade **E**  
Clarity Grade **VS 1**  
Depth **62.2%**  
Table **65%**  
Girdle **Medium To Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG783624870**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa